



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829
Examiner: J. Hollington

4-26
1310
4-17-03
J. Hollington

In Re NEW PATENT APPLICATION Of:

Applicant: Mikio OHTAKI)
Appln. No.: 09/904,663)
Filed: July 16, 2001)
For: METHOD FOR MANUFACTURING)
AND BATCH TESTING)
SEMICONDUCTOR DEVICES)
(As Amended))
Atty Ref.: KAN 120D1)

**AMENDMENT
AFTER FINAL**

April 10, 2003

Commissioner for Patents
Washington, D.C. 20231
BOX - AF

Sir:

Responsive to the Examiner's Action dated December 10, 2002, a Petition
for a One-Month Extension of Time being submitted herewith, please amend the
application as follows:

IN THE SPECIFICATION

Please replace the title on page 1 of the Specification with the following:

--METHOD FOR MANUFACTURING AND BATCH TESTING
SEMICONDUCTOR DEVICES --

FEES ENCLOSED \$ 110.
Please charge any further
fee to our Deposit Account
No. 10-0002

RECEIVED
MAY 10 2003
TECHNICAL SERVICES
800

O.K. x0
enter J. H.